Room-temperature sensing performance of hydrogen using palladium-based film by optical setup

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 H_2 sensing performance of novel Pd–Pt alloy films has been compared with those obtained by using Pd films and H_2 -reducted PdO films. Two different detecting systems were used to measure the hydrogenation and de-hydrogenation phases with a H_2 concentration of both 5% v/v nitrogen and 1% v/v nitrogen at room temperature. The sensitivity loss observed for the Pd–Pt alloy and H_2 -reducted PdO samples with respect to pure Pd samples can be explained in terms of the reduction in the lattice constant and interstitial volume due to the Pt addition, which determine a decrement of hydrogen atoms penetrating in the films. On the other hand, results show an improvement in time -response for Pd–Pt alloy and H_2 -reducted PdO films with respect to pure Pd ones, presumably due to the increase of its permeability to H_2 . Moreover, the sensing measurements repeated after 60 days show that the Pd–Pt alloy films, unlike the Pd-based ones, fully preserve their performances, demonstrating the advantage of the Pt inclusion for stability purposes when the samples are stored upon humidity.

Keywords: hydrogen detection, palladium-based film, palladium-platinum alloy film, optical sensor.

1. Introduction

Hydrogen (H_2) has received a great deal of attention in numerous applications, including those which are interesting for chemical industry, clean fuels production and food pro-

cessing [1-6]. H₂ is a tasteless, odorless, colorless and inflammable gas which becomes explosive at concentrations higher than 4% in air, making the development of hydrogen sensors very crucial. There are several hydrogen sensing techniques, such as those based on thermal, electrochemical, mechanical, optical and acoustic effects; among them, the optical one is the most suitable and safe to be applied in the hydrogen atmosphere [7, 8]. Palladium (Pd) is a widely used catalyst in the field of optical and conductive sensors since it demonstrates a valuable native sensitivity towards hydrogen. In fact, a significant change in the optical and electrical properties can be detected when Pd is exposed to hydrogen because of the formation of hydrides [9-14]. The change in Pd optical response is due to absorption of atomic hydrogen, after decomposition of its molecules at the metal surface, and to the hydrogen atoms diffusion in the metal lattice [15-17]. In case of low partial pressure, the number of atoms diffused into Pd is moderate, the distance between the hydrogen atoms is large and the compositional strain induced in the Pd lattice is weak; such solid solution is called α -phase. When the hydrogen partial pressure increases, the number of hydrogen atoms in the metal, as well as their mutual interactions resulting from lattice strain and electronic interactions, also increase, leading to the formation of the hydride, called β -phase. For hydrogen concentrations above 4%, the hydride formation is considered complete at the expense of the α -phase regions.

To improve the efficiency of the Pd sensors, different strategies were proposed, as well as various solutions to avoid temperature, humidity, and oxygen concentration performance dependence. Benefits in performance derive from higher film porosity and/or surface nano-structuring, which results in the increase of the effective surface-to-volume ratio [18–21]. However, Pd-based sensors stability is affected by the structural changes induced by the volume expansion [17]. Moreover, the response times of Pd-based sensors are determined by the dynamic equilibrium process involving hydrogen adsorption/desorption at the films surface, bulk diffusion and Pd hydride formation, which in case of pure Pd films results in limited performance.

The use of Pd alloy thin films such as Pd-Ag, Pd-Ni and Pd-Y has been demonstrated to reduce response and recovery times, due to the increased permeability of the alloy to H₂, and to stabilize the properties of the sensor over time $[\underline{22}-\underline{26}]$. Platinum (Pt) is also a common material applied in hydrogen sensing [27-30]. While Pd has good selectivity toward hydrogen but with poor stability, Pt has good stability in air and it can be used also as a protective layer of the sensing media [31, 32]. Nano-porous Pt samples have been also proven to have higher sensitivity with respect to pure platinum samples [33]. Given these premises, it is expected that Pd–Pt composite films can exhibit interesting catalyst properties and higher stability [34, 35]. In the present work, we compare the sensing performance of novel Pd–Pt alloy films with pure Pd films as well as those obtained by H_2 -reduction of PdO, previously studied [20]. The Pd–Pt alloys operated reversibly upon H₂ absorption and desorption. The absorbance change was characterized for two different H_2 concentrations (1% or 5% v/v nitrogen) at room temperature. Two different detecting systems were used to record the hydrogenation and de-hydrogenation phases signal. The sensitivity loss with respect to pure Pd samples can be explained in terms of the reduction in the lattice constant and interstitial volume due to

the Pt addition, which determine a decrement of hydrogen atoms penetrating in the alloy [22]. Interestingly, results show an improvement in time-response of Pd–Pt alloy films with respect to Pd ones, presumably due to the increase of its permeability to H_2 . Moreover, the sensing measurements repeated after 60 days show that the Pd–Pt alloy films, unlike the Pd-based ones, fully preserve their performances, demonstrating the advantage of the Pt inclusion for stability purposes.

2. Materials and methods

Palladium films were deposited on quartz substrate using e-beam evaporation technology. The base vacuum during the deposition process was about 10^{-4} Pa (10^{-6} mbar) while the temperature of the substrate was controlled to be around 90°. The growth rate of the films was constant, being 0.5 nm/s. The final thickness of the Pd films was 12.7 nm. Some of the samples were then oxidized by annealing at 600° in a vacuum of about 1.5 mbar for 2 h; the annealing time was chosen in order to ensure the full oxidation of the film [20]. Afterwards, the oxidized samples were exposed for 15 min to H₂ atmosphere (5% v/v nitrogen) at room temperature to obtain the reduced-Pd (r-Pd) samples by inducing the H₂-reduction process described by the following chemical reaction:

$$PdO + H_2 \rightarrow Pd + H_2O \tag{1}$$

The Pd/Pt alloy (Pd-Pt_al) films were fabricated starting from Pd/Pt multilayer (Pt-Pt_ml) films [<u>36</u>]. Such multilayers were deposited on quartz substrates using direct current (DC) magnetron sputtering technology. The base vacuum was 2.5×10^{-4} Pa (2.5×10^{-6} mbar) and high purity argon (99.999%) was used as working gas at a pressure of 0.200 Pa. The effective deposition rates were 0.105 nm/s for Pd and 0.145 nm/s for Pt. The final structure of the multilayer was a stack of three Pd(2 nm)/Pt(2 nm) bi-layers over-coated with an additional Pd layer of 2 nm. Afterwards, the mixture of the individual Pd and Pt layer was induced by means of two thermal and H₂-reduction cycles. During the thermal process, the samples were annealed at 600° for 2 hours in vacuum (1.5 mbar). During the H₂-reduction process, the samples were exposed for 15 min to H₂ atmosphere (5% v/v nitrogen) at room temperature.

After deposition, the thickness of the films was determined using a profilometer, KLA Tencor P-16+, and the morphology of the surface was evaluated by a non-contact Park-System XE-70 atomic force microscope (AFM). Furthermore, the Pd/Pt samples were characterized before and after each thermal/H₂-reduction process with X-ray reflectivity (XRR) at the Cu K- α ($\lambda = 1.54$ Å) emission in order to confirm the formation of the Pd–Pt alloy. XRR were performed using a Philips MRD diffractometer, equipped with a parabolic multilayer mirror for primary beam conditioning. The reflected beam was measured as a function of the incidence angle by a proportional Xe counter, coupled to a parallel plate collimator with an angular acceptance of 0.01°. XRR measurements were taken for grazing angles ranging from 0.01° to 3°, with a step of 0.005°. XRR curves were fitted using IMD software [<u>37</u>] assuming as free parameters the layer



Fig. 1. Sketch of the setup to measure the gas sensing performance.

thicknesses, the material densities (both film and substrate), and the interface roughness. To carry out such fits, the Pd and Pt layers were modelled considering the atomic scattering factors provided by HENKE *et al.* [<u>38</u>]; the interface roughness was described by the Nevot–Croce model [<u>37</u>].

The optical transmittance of the films was measured using a double grating spectrophotometer (Varian Cary5000) in the 300–1700 nm spectral range.

The gas sensing performances of the as-deposited Pd, r-Pd and Pd-Pt_al films were tested in the 400–800 nm spectral range. A sketch of the experimental setup adopted is reported in Fig. 1. A sealed flow cell (with a volume of about 43 ml) is coupled with a flowmeter for monitoring the gas flux. The beam coming from a collimated halogen lamp is used as a test beam for the transmittance/absorbance measurements. The optical absorbance was measured by using an Ocean Optics USB4000 spectrometer and a Thorlabs PDA100A-EC photodiode simultaneously.

The tests were carried out by alternating the $H_2(1\% \text{ or } 5\% \text{ v/v} \text{ nitrogen})$ atmosphere with the dry air at room temperature $(22 \pm 2^\circ)$. The exposures sequences started by fluxing dry air into the flow cell for 5 min in order to set the initial atmosphere. Afterward, the H_2 at the desired concentration was fluxed for 5 min and then replaced with dry air for another 5 min. These two steps were then repeated many times. The flow rate was set as 0.8 l/min to ensure sufficient time and turbulence of gas recycling inside the flow cell and reacting with the sample.

The transmittance signal was acquired by a photodiode. The direct and transmitted beam signals were measured and the dynamic integrated absorbance A_{phot} obtained. Addionally, for comparison, the dynamic relative integrated absorbance $A_{\Delta\lambda}$ was obtained by making the integral over the 400–800 nm range of the absorbance values $A(\lambda) = \log(I_0(\lambda))/(I_T(\lambda))$, where $I_T(\lambda)$ is the transmittance signal provided by the spectrometer and $I_0(\lambda)$ the reference one:

$$A_{\Delta\lambda} = \frac{1}{\lambda_2 - \lambda_1} \int_{\lambda_1}^{\lambda_2} A(\lambda) d\lambda$$
⁽²⁾

3. Results and discussions

The thickness of the Pd films measured prior, after annealing and after H₂-reduction is reported in the Table. Since Pd crystallizes in a *fcc* structure (a = 3.882 Å with four atoms per cubic unit cell) and PdO has a tetragonal structure (a = 3.043 Å, c = 5.336 Å with two Pd atoms per unit cell), the thickness of a Pd film that is completely oxidized to PdO should increase by a factor of $(4(a^2c)_{PdO})/2(a^3)_{Pd} = 1.68$ [20]. However, the annealed films considered in the present study increased by a factor ranging from 3.7–4.2 with respect to the original thickness, suggesting that the PdO film is highly porous. This porosity is preserved also after the H₂-reduction, as the contraction undergoing by the films does not restore the original thickness.

Process	Thickness [nm]	
	Pd sample	Pd/Pt sample
As deposited	12.7	14.4
After oxidation	51.0	24.7
After reduction	38.3	18.3

T a b l e. Pd and Pd/Pt typical sample thickness along the annealing/H2-reduction process.

The Pd/Pt samples thickness changes along the processes is reported in the Table. Pt crystalizes in a *fcc* structure (volume = a^3 , a = 3.92 Å and four atoms per unit cell) and its oxide is formed at temperatures higher than 870°C. It is thus reasonable to consider that the adopted thermal process cannot induce the Pt oxidation and the annealed films will be composed by an alloy of Pt and PdO. Based on this assumption, the thickness expansion which underwent after thermal process should be of a factor of

$$\frac{\frac{1}{2}(a^2c)_{\rm PdO} + \left(\frac{N_{\rm Pt}}{N_{\rm Pd}}\right) \frac{1}{4}(a^3)_{\rm Pt}}{\frac{1}{4}(a^3)_{\rm Pd} + \left(\frac{N_{\rm Pt}}{N_{\rm Pd}}\right) \frac{1}{4}(a^3)_{\rm Pt}} = 1.39$$
(3)

where N_{Pt} and N_{Pd} are the atomic number density of Pt and Pd, respectively. However, all the films considered in the present study showed a thickness increase of a factor ranging from 1.71 to 1.77, slightly higher than the theoretical one. Again, this discrepancy can be still explained considering an increase of the porosity due to the thermal process.

The XRR curves of a Pd/Pt sample before and after annealing/H₂-reduction cycles are reported in Fig. 2. In the as-deposited Pd/Pt sample, the XRR was fitted by considering a multilayer model with a period thickness of 4.02 nm, a thickness ratio $d_{Pd}/(d_{Pd} + d_{Pt})$ of 0.50, a Pd density ρ_{Pd} of 11.95 g/cm³, a Pt density ρ_{Pt} of 20.58 g/cm³, a Pt on Pd roughness σ_1 of 0.20 nm and a Pd on Pt roughness σ_2 of 0.26 nm. On the



Fig. 2. XRR result of the Pd/Pt sample before and after processes. Before: Pd-Pt_ml film (a), after: Pd-Pt_al film (b).

other hand, the XRR measured after the thermal/ H_2 -reduction cycle revealed a curve which can be successfully fitted with a Pd–Pt alloy monolayer model with a thickness of 23.01 nm and a density of 13.43 g/cm³. The retrieved film density, which is lower



Fig. 3. The topography of all the samples by AFM. Pd film, roughness $r_q = 0.525$ nm (**a**), r-Pd film, roughness $r_q = 8.954$ nm (**b**), and Pd-Pt_al film, roughness $r_q = 6.305$ nm (**c**).



Fig. 4. The dynamic integrated absorbance A_{phot} of Pd, r-Pd and Pd-Pt_al samples along different cycles. H₂ concentration of 5% (**a**) and of 1% (**b**).

with respect to the theoretical one (*i.e.* $\rho = 15.64$ g/cm³), and the final thickness, which is higher than the initial value, suggests that the films are still porous.

The morphologies of all the samples are investigated by AFM as showed in Fig. 3. Nano-bubbles appear on the surface of Pd-Pt_al and r-Pd samples, as confirmed by the root mean square (RMS) roughness data. The lines of the as-deposited Pd sample come from the fabrication of the substrate.

The dynamic integrated absorbance A_{phot} of the Pd, r-Pd and Pd-Pt_al was acquired along different cycles. The results are reported in Fig. 4**a** for the case 5% H₂ concentration and Fig. 4**b** for the case 1% H₂ concentration.

According to the profiles in Fig. 4, three different features have been analyzed: the OAC (optical absorbance change), calculated as the average of the steps for each cycle; the response time, calculated as the average time to the change from 5% to 95% of the absorbance when switching form air to H₂; the recovery time, calculated as the average time to the change from 4_2 ; the recovery time, calculated as the average time to the change from 4_2 ; the recovery time, calculated as the average time to the change from 4_2 ; the recovery time, calculated as the average time to the change from 4_2 ; to 4_2 ; the recovery time, calculated as the average time to the change from 4_2 to air.

The OAC, representing the sensitivity of the sample, is reported in Fig. 5. As expected, the Pd-Pt_al sample shows lower sensitivity than both the Pd and r-Pd ones if we consider the 5% H_2 concentration case; on the contrary, it shows comparable performance for the case of 1% H_2 concentration. In this last case, the r-Pd offers the better results. The sensitivity loss of Pd-Pt_al with respect to pure Pd and r-Pd samples can be explained in terms of the reduction in the lattice constant and interstitial volume due to the Pt addition.

The response time and recovery time for all the different samples (Pd, r-Pd and Pd-Pt_al) are plotted in Fig. 6. Interestingly, the response of the treated samples, means Pd-Pt_al and r-Pd, are quicker than the Pd virgin sample, especially when considering the recovery time in the 5% H₂ concentration case. This can be explained in terms of induced porosity in the treated samples, which allows a higher gas flushing through the films. On the other hand, the reduction of interstitial volume due to the Pt addition in Pd-Pt_al sample decreases the performance of it with respect to the r-Pd sample.



Fig. 5. Sensitivity of Pd, r-Pd and Pd-Pt_al samples along different cycles with a H_2 concentration of 5% and 1% measured both with spectrometer and photodiode.



Fig. 6. Response performance of all samples with H_2 concentration of 5% and 1%. Response (a) and recovery (b) times.

Considering that the performance obtained from the r-Pd sensors are comparable or, even, better than standard Pd sensors, the aging effects induced by regular environment storing have been investigated by considering the r-Pd samples as representative of the pure Pd-based sensors. The Pd-Pt_al and r-Pd samples have been stored in air at ambient temperature for 60 days, and response tests then repeated (Fig. 7). In previous studies, it has been demonstrated that Pd-based hydrogen sensors are highly affected by the environmental humidity, reducing the sensibility and the response time [26, 39]. These effects are mainly due to the Pd surface-catalyzed reactions with H₂O occurring when a Pd film with a thin layer of H₂O on top reacts with H₂ [26]. Similarly to what has been observed in previous studies for the standard Pd-based sensors, the reduction of performance due to humidity is clearly recognizable also in r-Pd samples tested after 60-days in regular environment (see Fig. 7). The use of Pt alloyed with Pd contributes to reduce the impact of the surface reactions on the sensing performance. In fact, the cycle of Pd-Pt al sample is complete from the second cycle while that of



Fig. 7. The sensing performance cycles of samples Pd-Pt_al (Pd/Pt alloy film) and r-Pd (reduced Pd film) after 60 days.

r-Pd sample is complete from the fourth cycle, showing the improved stability obtained in the Pd-Pt_al.

4. Conclusions

The hydrogen sensing performance of Pd, r-Pd and Pt-Pd al thin film samples has been investigated. The r-Pd samples have been fabricated by high-temperature reaction and reduction process starting from a palladium thin film; the Pd–Pt alloy monolayer films have been fabricated by inducing an intermixing of the layers of Pd/Pt multilayers using two cycles of high-temperature reaction and reduction process. The samples have been tested by measuring the modification of the absorbance in alternative atmospheres of H₂ (1% or 5% v/v nitrogen) and dry air at room temperature ($22 \pm 2^{\circ}$ C). The data have been acquired simultaneously by a spectrometer and a photodiode, which provide two independent sets of measurement with an excellent agreement. The response and recovery time of the treated sample are quicker than the standard palladium film one, due to the increase of the porosity of the films. The Pd-Pt al film shows lower sensitivity than the Pd film r-Pd film due to the lower concentration of adsorption sites of hydrogen. The r-Pd shows enhanced sensitivity at 1% hydrogen for the increase of the effective surface-to-volume ratio. After 60 days of the sample exploring in air, the cycle of Pd-Pt al sample completes quicker than the cycle of r-Pd sample, showing the stability profit from the doping of platinum.

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